

Notice of References Cited

Application/Control No.

09/387,477

Applicant(s)/Patent Under

Reexamination
TOMITA ET AL.

Examiner

Maria Guerrero

Art Unit

2822

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*	U	Rutherford et al. "A New Low Dielectric Constant Planarization Dielectric", IEE, 1991, pages 448-450.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.